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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Noriyoshi Matsumoto, et al.  
Serial No. : 10/775,683  
Filed : February 10, 2004  
For : OPTICAL MAGNIFICATION ADJUSTMENT SYSTEM  
AND PROJECTION EXPOSURE  
Examiner : Rutledge, Della J.  
Art Unit : 2851  
Attorney  
Docket No. : 424P061Div.

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In response to the Office Action dated June 2, 2004, please amend the  
above-identified application as follows:

**Amendments to the claims** begin on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

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P.O. Box 1450, Alexandria, VA 22313-1450

on July 29, 2004 (Date)

Kevin S. Lemack  
Name of applicant, assignee, or Registered  
Representative

[Signature]  
Signature

July 29, 2004  
Date